

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITSU et al.

Application No.: New U.S. National Stage of  
PCT/JP03/04408

Filed: September 27, 2004

Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR Al-CONTAINING III-V GROUP  
COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING  
Al-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

INFORMATION DISCLOSURE STATEMENT

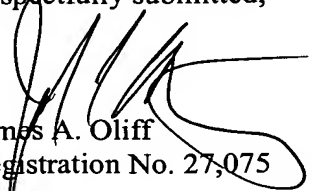
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references 1-2 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

  
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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 121213		APPLICATION NO. New U.S. National Stage of PCT/JP03/04408	
<b>INFORMATION DISCLOSURE STATEMENT</b>  (Use several sheets if necessary)				APPLICANTS Akinori KOUKITSU et al.			
				FILING DATE September 27, 2004		GROUP	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1.	EP 1 184 488 A2	3/6/2002	EUROPE			
	2.	WO 00/68470	11/16/2000	WIPO			
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: September 27, 2004